

**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

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of

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Application Number	09/828,049	RECEIVED
Filing Date	April 6, 2001	
First Named Inventor	Jason Souloglou	
Group Art Unit	2422 2192	MAR 20 2003
Examiner Name	To Be Assigned - Chih-Ching Chen	
Attorney Docket Number	032091.0003.CIP2	Technology Center 2100

U.S. PATENT DOCUMENTS						
Examiner Initials*	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code ² (if known)			

FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No. ¹	Foreign Patent Document			Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY
		Office ³	Number ⁴	Kind Code ⁵ (if known)		

NON PATENT LITERATURE DOCUMENTS						
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.				
C.C.		AHO, et al., "Chapter 9: Code Generation," <u>Compilers- Principles, Techniques, and Tools</u> , 522-584 (1986)				
		AHO, et al., "Chapter 10: Code Optimization," <u>Compilers- Principles, Techniques, and Tools</u> , 603-722 (1986)				
		WITCHEL, et al., "Embra: Fast and Flexible Machine Simulation," <u>Sigmetrics</u> , 68-79 (1996)				

Examiner Signature	<i>Chih-Ching Chen</i>	Date Considered	<i>2/3/06</i>
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation is not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Unique citation designation number. ² See attached Kinds of U.S. Patent Documents. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

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Examiner Name	To Be Assigned <i>Chih-Chang Chen</i>
Attorney Docket Number	032091.0003.CIP1

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